

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application.

Listing of Claims:

1. (Currently Amended) A method of manufacturing a plasma display panel, the method comprising the steps of:

providing a substrate holder including:

a first frame for holding a substrate of the plasma display panel, said first in which the plasma display panel is held by a substrate holder for deposition, wherein the substrate holder is configured with a plurality of frames, the substrate is held by its periphery with at least one of the frames, the substrate having a bottom surface, a top surface opposite the bottom surface and a side surface extending from the bottom surface to the top surface, and the frame holding the substrate has a protrusion extending from the below a bottom surface of the substrate along the a side surface of the substrate to a height greater than a height of the substrate without being superimposed over the top surface of the substrate; and

a second frame having an opening and situated adjacent to the first frame; and

providing the plasma display panel which is held by the substrate holder for deposition.

2. (Previously Presented) The method of manufacturing a plasma display panel as defined in Claim 1, wherein a height of the protrusion is between 1 mm and 100 mm.

3. (Currently Amended) The method of manufacturing a plasma display panel as defined in Claim 1, the first frame comprising holding means including support means for supporting the substrate from underneath and positioning means for positioning the substrate

in a planar direction, wherein the substrate is held by fitting the substrate to the positioning means and placing the substrate on the support means.

4. (Currently Amended) A substrate holder for a plasma display panel—~~used for deposition on a substrate of the plasma display panel, the substrate holder comprising:~~ being configured with a plurality of frames, the substrate being held by its periphery with at least one of the frames, the substrate having a bottom surface, a top surface opposite the bottom surface and a side surface extending from the top surface to the bottom surface, and

the—a first frame for holding the—a substrate of the plasma display panel, said first frame being provided with a protrusion extending from the—below a bottom surface of the substrate along a side surface of the substrate to a height greater than a height of the substrate without being superimposed over the top surface of the substrate, and

a second frame having an opening and situated adjacent to the first frame.

5. (Previously Presented) The substrate holder for a plasma display panel as defined in Claim 4, wherein a height of the protrusion is between 1 mm and 100 mm.

6. (Currently Amended) The substrate holder for a plasma display panel as defined in Claim 4, the first frame comprising holding means including support means for supporting the substrate from underneath and positioning means for positioning the substrate in a planar direction, wherein the substrate is held by fitting the substrate to the positioning means and placing the substrate on the support means.

7. (New) The substrate holder for a plasma display panel as defined in Claim 4, wherein the first frame includes a plurality of tabs separated from each other which extend below the bottom surface of the substrate.

8. (New) The substrate holder for a plasma display panel as defined in Claim 4, said second frame maintained with said opening while said substrate is situated in said first frame.